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Docket No.: 8734.231.00  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:  
Sang-Hyun KIM

Confirmation No. 9240

Application No.: 10/661,486

Art Unit: 2813

Filed: September 15, 2003

Examiner: Laura M. Schillinger

For: METHOD OF FABRICATING  
POLYCRYSTALLINE SILICON THIN FILM  
FOR IMPROVING CRYSTALLIZATION  
CHARACTERISTICS AND METHOD OF  
FABRICATING LIQUID CRYSTAL DISPLAY  
DEVICE USING THE SAME

Customer No.: 30827

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

In response to the Non-Final Office Action dated June 28, 2005 Applicant hereby requests entry of the following amendments.

**INTRODUCTORY COMMENTS**

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.